The Possibilities and Challenges of Photobase Generators for Oxa-Michael Reactions

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Step-growth polymerization is still highly valued in the field of additive manufacturing to produce tougher materials compared to free radical polymerization. Thiol-ene chemistry sees widespread use in this application, yet, it has its drawbacks, such as the availability of thiols, their strong odor, and a low storage stability.^{1,2} Switching from sulfur to oxygen enables a wider variety of available monomers without the odor. The oxa-ene reaction is a base catalysed Michael-type reaction with recent research finding highly effective Lewis-base catalysts.³ Our work includes the transition from a free base catalysed system to light triggered systems using our novel Lewis photobase generators. These were applied for both model reactions and polymeric formulations. Former allowed for an indepth investigation of the mechanism alongside the high storage stability of the system. As the reaction speed was higher at elevated temperatures, our polymeric system was a perfect fit for Hot Lithography yielding 3D-printed parts with high resolution.⁴

References

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